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working for Metrology Light Source(MLS)

Background:

- I. Pulsed HV thermionic guns and RF guns
- II. Beam dynamics simulations of FEL injector

Task now:

- Operation and upgrade of MLS
- A new optics for users
- To know and learn from outstanding lecturers and nice colleagues at CAS



MLS:

A reference source in the Extreme Ultraviolet (EUV) regime for metrology applications

